

- Large silicon assembly lab
- Temperature: 70 degree F
- humidity: 50%
- T, H are adjustable in clean silicon lab to ensure good conditions and avoid any static charges.



Several desiccators to store components, chips, sensors, ladders.

Dry air and nitrogen injected into desiccators:

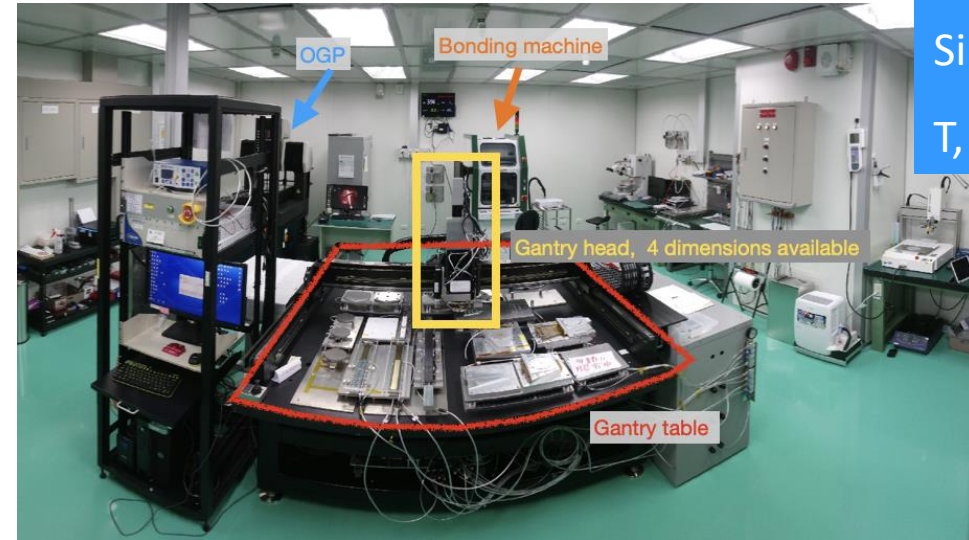
Dew point 0 to 1%

Degree C



Taiwan Silicon Detector Facility (TSiDF)

- 2 clean rooms + 1 module testing lab
- Main instruments :
 - Probe station
 - Gantry
 - Bonding machine
 - INTT Testbench
 - Climate chamber



Similar conditions
T, H as BNL

